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ATENT APPLICATION of:

Confirmation Number: 9080

VAN ZWET ET AL.

Application No.: 10/734,642

Group Art Unit: 2851

Filed: December 15, 2003

Examiner: Hung Nguyen

Title: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AMENDMENT

United States Patent and Trademark Office Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Office Action dated June 6, 2006, a Request for Continued Examination being filed herewith, please amend the above-identified application as follows: